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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a 371 of PCT/JP04/03808 03/19/2004 JL

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2003-078002 03/20/2003 JL

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 21	<b>TOTAL CLAIMS</b> 11	<b>INDEPENDENT CLAIMS</b> 3
35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance JL				
Verified and Acknowledged <u>Examiner's Signature</u> Initials JL				

## ADDRESS

53080

## TITLE

Finfet-type semiconductor device and method for fabricating the same

<b>FILING FEE RECEIVED</b> 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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